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Applicant: Christoph A. Wasshuber Art Unit: 2818
Serial No.: 10/714,366 Examiner: Nguyen, T.
Filing Date: 11/13/2003 Docket No.: TI-36280
Customer No.: 23494 Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A
SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH
PROCESSES

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NAME OF INVENTOR(S): Wasshuber	
TITLE OF INVENTION: FORMING A SEMICONDUCTOR . .	
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